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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Chung-En Kao

Serial No. 09/ 976,082

Group Art Unit: 1753

Filed: Oct. 12, 2001

Examiner: Steven H. Versteeg

For: Apparatus and Method for Self-Centering a Wafer in a Sputter Chamber

Attorney Docket No.: 67,200-530

Box Official Draftsperson
Commissioner for Patents
Alexandria, VA 22313-1450

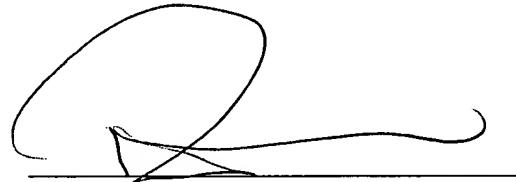
TRANSMITTAL OF FORMAL DRAWINGS

In response to the Notice of Allowability mailed on December 31, 2003, attached please find:

(a) the formal drawing(s) for this application.

Number of Sheet(s) 2

■ Each sheet of drawing(s) indicates the identifying indicia



SIGNATURE OF ATTORNEY
Randy W. Tung (31,311)

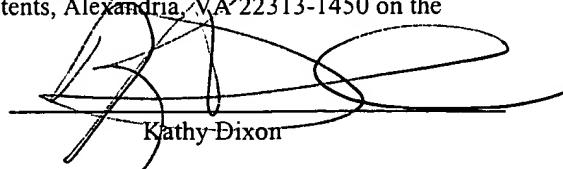
Reg. No.: 31,311

Tel. No.: (248) 540-4040

Tung & Associates
P.O. Address
838 W. Long Lake Road, Suite 120
Bloomfield Hills, Michigan 48302

CERTIFICATE OF MAILING (37 C.F.R. 1.8(a))

I hereby certify that this correspondence is being deposited with the Official Draftsperson, Commissioner for Patents, Alexandria, VA 22313-1450 on the date indicated below.



Kathy Dixon

Date: March 24, 2004